TRANSMITTAL FORM

Attorney Docket No. P3P2000078US 2369NP

In re the application Yuji Okuta P

Confirmation No: 1643

Serial No: 10/018,708

Group Art Unit: 3723

Filed: December 13, 2001

Examiner: Wilson, Lee D.

For: Table of Wafer Polishing Apparatus, Method for Polishing Semiconductor Wafer, and Method for Manufacturing Semiconductor Wafer										
ENCLOSURES (check all that apply)										
	Amendment/	Repl	у		Assignment and Recordation Cover Sheet			After Allowance Communication to Group		
	After Final				Part B-Issue Fee Transmittal			Notice of Appeal		
	Information disclosure statement				Letter to Draftsman			Appeal Brief		
	Form 1449				Drawings			Status Letter		
	(X) Copies of References				Petition			Postcard		
	Extension of Time Request *				Fee Address Indica	tion Form		Other Enclosure(s) (please identify below):		
	Express Abandonment				Terminal Disclaimer					
	Certified Copy of Priority Doc				Power of Attorney and Revocation of Prior Powers					
	Response to Incomplete Appln				Change of Correspondence Address					
	Response to	Miss	sing Parts	*Extension of Term: Pursuant to 37 CFR 1.136, Applicant petitions the Commissioner to extend the time for response for xxxxxx month(s),						
	Execut Inventor		eclaration by	from to .						
CLAIMS										
			Claims Remain After Amendme		Highest # of Claims Previously Paid For	Extra Claims		RATE	FEE	
	Claims		37		42	0		\$ 50.00	\$ 0.00	
Independent Claims			2		3	0		\$200.00 Total Fees	\$ 0.00 \$ 0.00	
METHOD OF PAYMENT										
	Check no in the amount of \$ is enclosed for payment of fees.									
	Charge \$ to Deposit Account No (Account Holder Name) for payment of fees.									
	Charge any additional fees or credit any overpayment to Deposit Account No. <u>02-2120</u> (Sawyer Law Group)									
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT										
Attorney Name Joseph A. Sawyer, Jr., Reg. No. 30, 801										
Signature Statement of the Signature Signature										
Date July 1, 2005										
CERTIFICATE OF MAILING										
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Step AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 1, 2005										
Type or printed name										
Signature Trans Protogo										

Attorney Docket: 2369NP

CERTIFICATE OF MAIL

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 1, 2005

Irena Nikolova

JUL 0 5 2005 JUL 1 PRADEMARY OF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Yuji Okuda

Confirmation No.: 1643

Serial No: 10/018,708

Group Art Unit: 3723

Filed: April 15, 2002

Examiner: Wilson, Lee D

For:

TABLE OF WAFER POLISHING APPARATUS, METHOD FOR POLISHING

SEMICONDUCTOR WAFER, AND METHOD FOR MANUFACTURING

SEMICONDUCTOR WAFER

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Final Office Action dated March 31, 2005, please amend the aboveidentified application in the following manner:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.